

09/918,167

Amendments to the Specification

Please replace the paragraph beginning at page 29, line 2 with the following paragraph:

~~Ion texturing methods and articles are disclosed. The invention described herein relates to ion texturing a nontextured surface while exposing the surface to one or more reactive species, such as nitrogen and/or oxygen to form a biaxially textured surface having a different chemical composition than the nontextured surface.~~

Please replace the paragraph beginning at page 1, line 2 through page 2, line 8 with the following paragraph:

INCORPORATION BY REFERENCE

~~The following documents are hereby incorporated by reference: U.S. Patent No. 5,231,074, issued on July 27, 1993, and entitled "Preparation of Highly Textured Oxide Superconducting Films from MOD Precursor Solutions," U.S. Patent No. 6,022,932, issued February 8, 2000, and entitled "Low Vacuum Process for Producing Superconductor Articles with Epitaxial Layers," U.S. Patent No. 6,027,564, issued February 22, 2000, and entitled "Low Vacuum Process for Producing Epitaxial Layers," U.S. Patent No. 6,190,752, issued February 20, 2001, and entitled "Thin Films Having Rock-Salt Like Structure Deposited on Amorphous Surfaces," PCT Publication No. WO 00/58530, published on October 5, 2000, and entitled "Alloy Materials," PCT Publication No. WO/58044, published on October 5, 2000, and entitled "Alloy Materials," PCT Publication No. WO 99/17307, published on April 8, 1999, and entitled "Substrates with Improved Oxidation Resistance," PCT Publication No. WO 99/16941, published on April~~

09/918,167

~~8, 1999, and entitled "Substrates for Superconductors," PCT Publication No. WO 98/58415, published on December 23, 1998, and entitled "Controlled Conversion of Metal Oxyfluorides into Superconducting Oxides," PCT Publication No. WO 01/11428, published on February 15, 2001, and entitled "Multi Layer Articles and Methods of Making Same," PCT Publication No. WO 01/08232, published on February 1, 2001, and entitled "Multi Layer Articles And Methods Of Making Same," PCT Publication No. WO 01/08235, published on February 1, 2001, and entitled "Methods And Compositions For Making A Multi Layer Article," PCT Publication No. WO 01/08236, published on February 1, 2001, and entitled "Coated Conductor Thick Film Precursor", PCT Publication No. WO 01/08169, published on February 1, 2001, and entitled "Coated Conductors With Reduced A.C. Loss" PCT Publication No. WO 01/15245, published on March 1, 2001, and entitled "Surface Control Alloy Substrates And Methods Of Manufacture Therefor," PCT Publication No. WO 01/08170, published on February 1, 2001, and entitled "Enhanced Purity Oxide Layer Formation," PCT Publication No. WO 01/26164, published on April 12, 2001, and entitled "Control of Oxide Layer Reaction Rates," PCT Publication No. WO 01/26165, published on April 12, 2001, and entitled "Oxide Layer Method," PCT Publication No. WO 01/08233, published on February 1, 2001, and entitled "Enhanced High Temperature Coated Superconductors," PCT Publication No. WO 01/08231, published on February 1, 2001, and entitled "Methods of Making A Superconductor," U.S. Patent Application Serial No. 09/579,193, filed on May 26, 2000, and entitled, "Oxide Bronze Compositions And Textured Articles Manufactured In Accordance Therewith," U.S. Patent Application Serial No. 09/694,400, filed on October 23, 2000, and entitled "Precursor Solutions and Methods of Using~~

09/918,167

~~Same," and U.S. Patent Application Serial No. 09/855,312, filed on May 14, 2001, and entitled "Precursor Solutions and Methods of Using Same."~~